

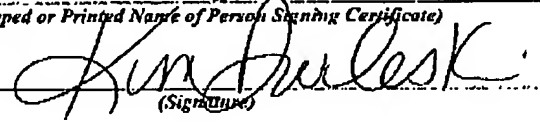
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CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8) Applicant(s): Anthony J. Stamper			Docket No. BUR920030189US1	
Application No. 10/709,722	Filing Date 5/25/2004	Examiner Chu, Chris C.	Group Art Unit 2815	
Invention: METHOD OF FORMING A SEMICONDUCTOR DEVICE HAVING AIR GAPS AND THE STRUCTURE SO FORMED				
<p>I hereby certify that this <u>Request for Reconsideration (12 pages)</u> (Identify type of correspondence) is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>571-273-8300</u>) on <u>9/26/2005</u> (Date)</p> <p style="text-align: right;"><u>Kim Dwileski</u> (Typed or Printed Name of Person Signing Certificate)  (Signature)</p> <p style="text-align: center;">Note: Each paper must have its own certificate of mailing.</p>				

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DOCKET NO.: BUR920030189US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Anthony J. Stamper

Examiner: Chu, Chris C.

Serial No.: 10/709,722

Art Unit: 2815

Filed: 5/25/2004

For: **METHOD OF FORMING A SEMICONDUCTOR DEVICE HAVING AIR GAPS
AND THE STRUCTURE SO FORMED**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Request for Reconsideration

Sir:

This Request for Reconsideration is in response to the Office Action mailed June 27,
2005.

10/709,722

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